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Attorney's Docket No.: 7977-052001 / US3053

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani et al. Art Unit : 1765  
Serial No.: 08/690,747 Examiner : Robert Kunemund  
Filed : August 1, 1996  
Title: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Commissioner for Patents  
Washington, D.C. 20231

RESPONSE

In response to the action mailed May 18, 2001, please  
consider the remarks as follows:

REMARKS

Claims 21, 25, and 37-96 are pending in the application.

Claims 21, 25, and 37 are rejected under the judicially  
created doctrine of obviousness-type double patenting as  
allegedly being unpatentable over claims 1-48 of U.S. Patent No  
6,066,518. Applicant respectfully disagrees with this rejection  
and requests that this rejection be held in abeyance until the  
claims are finally deemed allowable over the prior art cited by  
the Examiner.

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October 17, 2001

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Veronica Whalen

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